

Search Notes

Application/Control No.

10/687,643

Examiner

Paul D. Kim

Applicant(s)/Patent under
Reexamination

MINO, TETSUYA

Art Unit

3729

SEARCHED

Class	Subclass	Date	Examiner
29	603.11 603.13- 603.16 603.18	7/5/2005	PK
360	121 122	7/5/2005	PK
	126 317	↓	
427	127 128	↓	
204	192.32- 192.34	7/5/2005	PK
216	22	↓	

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
Reviewed Parent Application 09/150,206 (US PAT. 6,188,544) 09/734,758 (ABN)	7/5/2005	PK
Textr Search EAST/NPL (IEEE)	7/6/2005	PK